Applicant: Serial No.:

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Leonard Forbes et al.

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Viet Nguyen

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METHOD FOR OPERATING A DEAPROM HAVING AN AMORPHOUS

SILICON CARBIDE GATE INSULATOR

INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE

Assistant Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450

In compliance with the duty imposed by 37, C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 et. seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Information Disclosure Statement.

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

LEONARD FORBES ET AL.

By their Representatives,

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Robert E. Mates

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner of Patents, P.O.Box 1450, Alexandria, VA 22313-1450, on this 25th day of July, 2003

Name

93/I.D.S. G. Storly 9-16-29